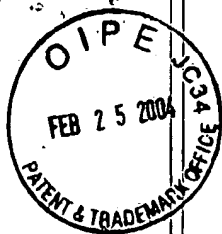


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Attorney Docket:
33082 M 083

RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE REQUESTED
GROUP 1763

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CONFIRMATION NO. 1607

Applicants : Yutaka TAKAHASHI, et al.
Serial No. : 09/864,374
Filed : May 25, 2001
Examiner : J. Lund
Art Unit : 1763
For : METHOD FOR FORMING OXYNITRIDE FILM OR THE LIKE
AND SYSTEM FOR CARRYING OUT THE SAME

AMENDMENT IN RESPONSE TO FINAL REJECTION

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 26, 2003, please amend the
above-identified application as set forth below and consider the following remarks.